



Attorney Docket 0553-0393

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
)
Shunpei Yamazaki et al.)
)
Serial No.: 10/757,167)
)
Filed: January 13, 2004)
)
For: Method For Manufacturing Conductive) Layer And Semiconductor Device)
)
Art Unit: 2822)
)
Examiner: Christy L. Novacek)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450 on

February 6 2006

(Date of Deposit)

Shannon Wallace
Name of applicant, assignee, or Registered Rep.

Shannon Wallace 2/6/06
Signature Date

AMENDMENT (C) AFTER FINAL

Sir:

In response to the Final Rejection of October 5, 2005 and the Advisory Action of January 20, 2006, a RCE and one month extension of time being submitted herewith, please amend the above-identified application as follows: